

Examiner: Tuan M.

Serial No.: 09/532,786

In re the Application of: HAYASHI, Nobuhiko

Filed: March 22, 2000

For. SEMICONDUCTOR LASER DEVICE AND METHOD OF FABRICATING T

SAME

PETITION FOR EXTENSION OF TIME

Commissioner for Patents Washington, D.C. 20231

Date: December 12, 2002

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated July 12, 2002 for two months from October 12, 2002 to December 12, 2002.

Attached please find a check in the amount of \$400.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. Two copies of this paper are enclosed herewith.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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400.00 OP

Attorney for Applicant

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GNS/alw

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